Fig. 1

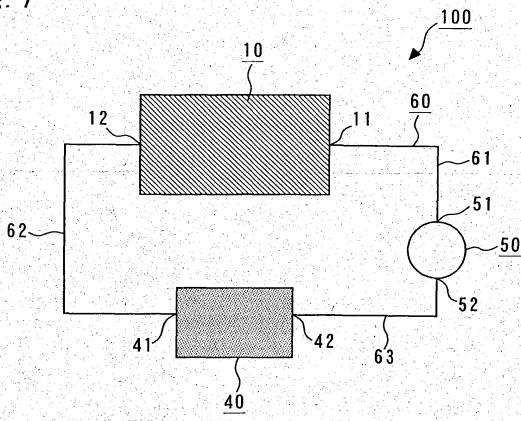
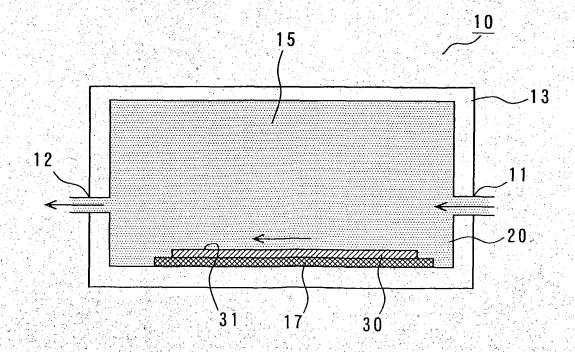


Fig. 2



Title: CHEMICAL PROCESSOR, CHEMICAL PROCESSING METHOD AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE
Inventors: NAKAMOTO et al.
Atty Docket No.: 402697
Leydig, Voit & Mayer 202-737-6770

Fig. 3

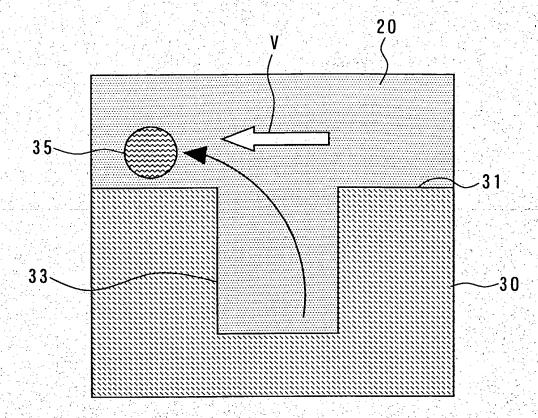
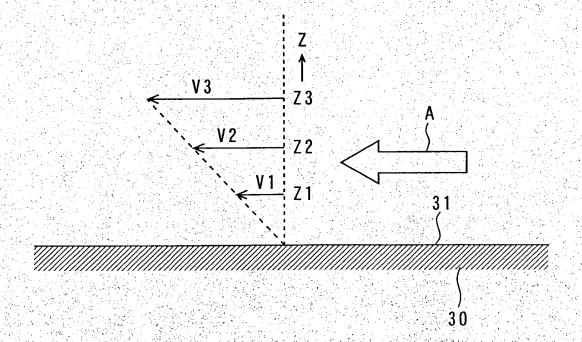
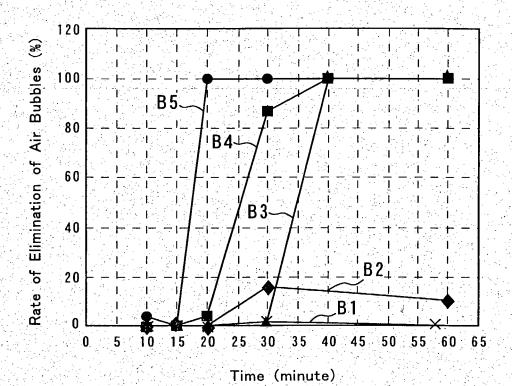


Fig. 4



SEMICONDUCTOR DEVICE Inventors: NAKAMOTO et al. Atty Docket No.: 402697 Leydig, Voit & Mayer 202-737-6770

Fig. 5



Title: CHEMICAL PROCESSING METHOD AND METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE
Inventors: NAKAMOTO et al.
Atty Docket No.: 402697
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Fig. 6

